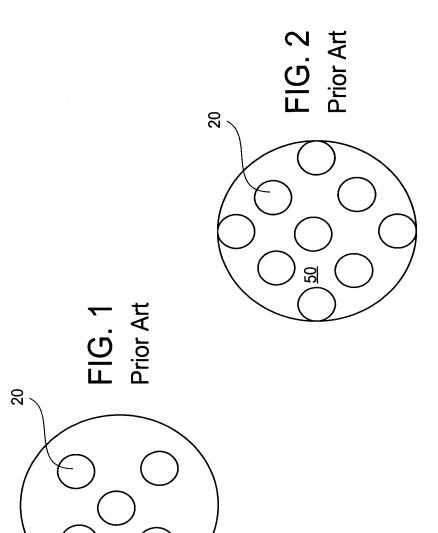


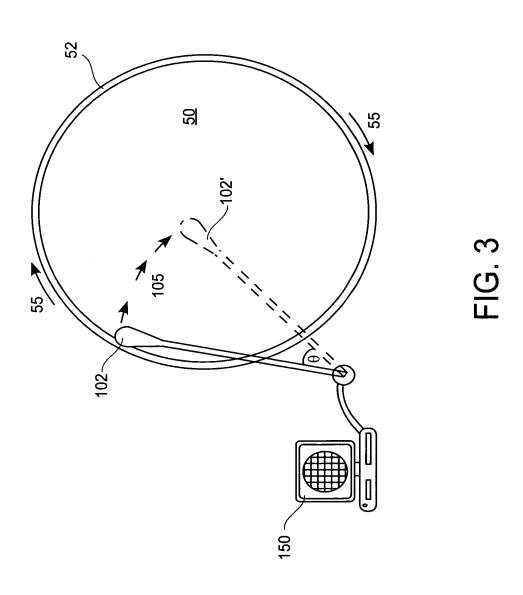
Title: METHOD AND APPARATUS FOR MEASUREMENT OF THIN FILMS AND RESIDUES ON SEMICONDUCTOR SUBSTRATES Inventor: Yehiel Gotkis

Docket No: LAM2P466 App. No: 10/810,209

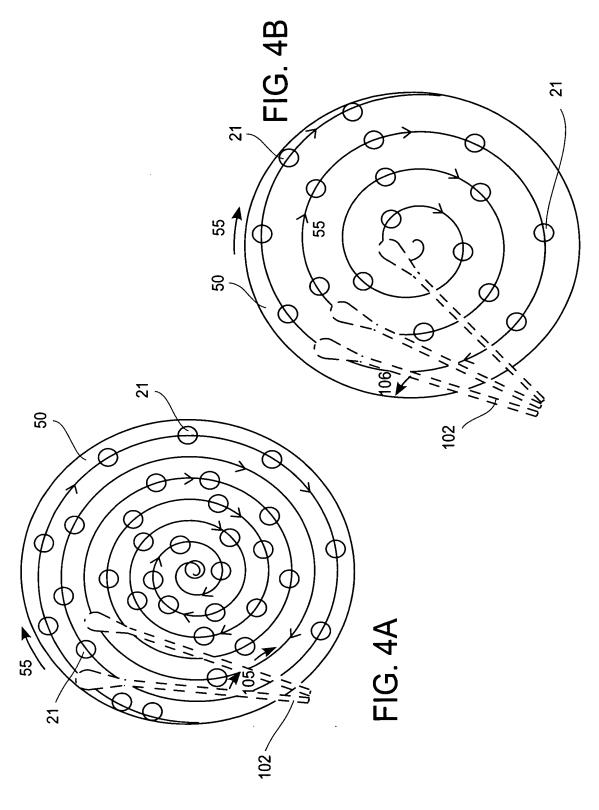


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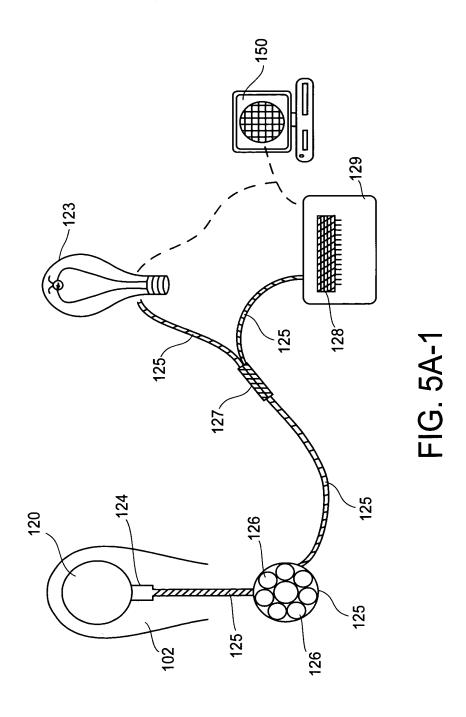
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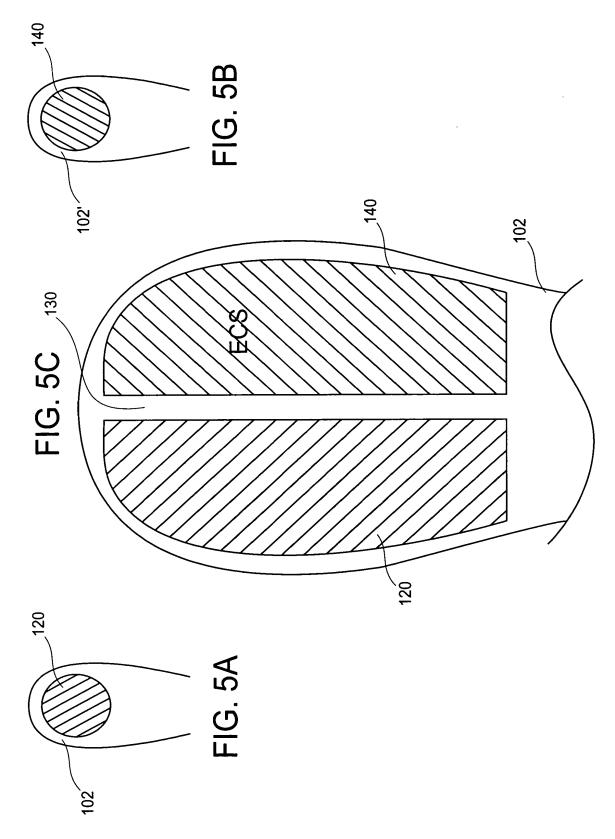
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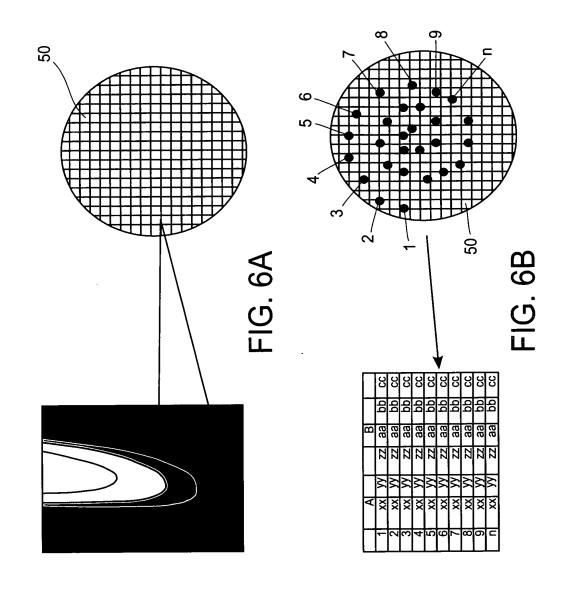


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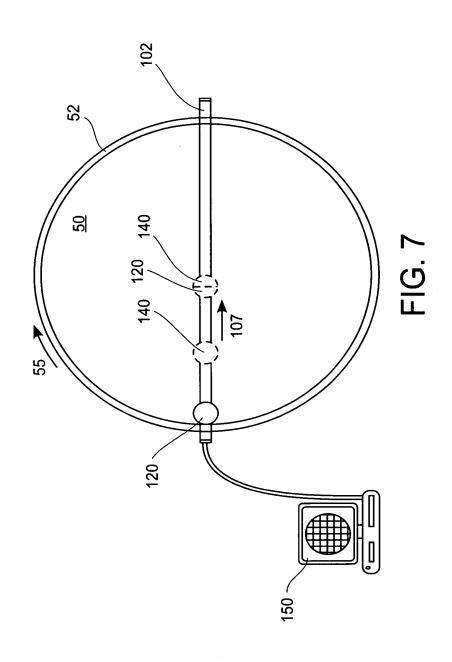


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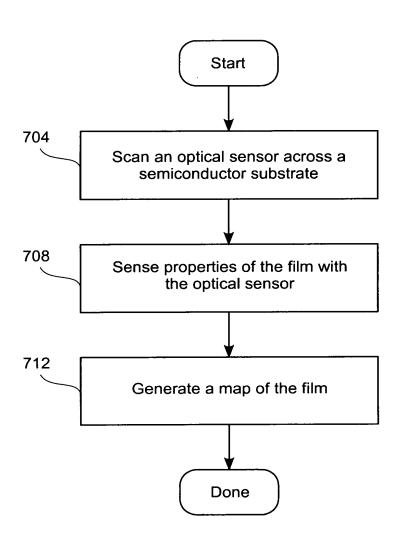


FIG. 8

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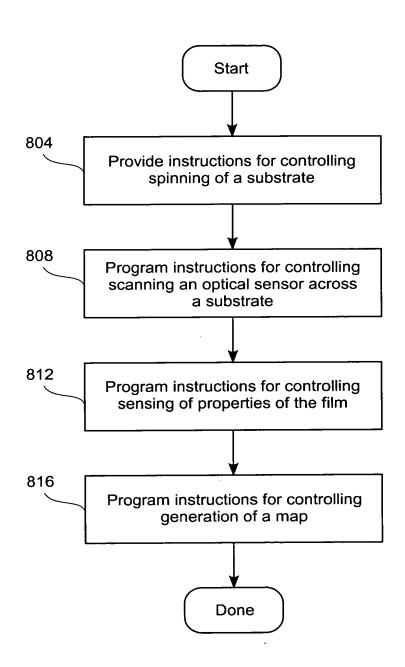


FIG. 9